

INFORMATION DISCLOSURE CITATION

(Use several sheets if necessary)

Docket number (Optional)

15689.49.4

Application Number

10/673,940

Applicant(s)

Takehiro Nakamura et al.

Filing Date

September 29, 2003

Group Art Unit

2611

U.S. PATENT DOCUMENTS

*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE

U.S. PATENT APPLICATION PUBLICATIONS

*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE

FOREIGN PATENT DOCUMENTS

	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
							YES	NO
	1	0 682 418 A2	05/12/1995	EPO	H0487	005	X	
	2	CN1126930	7/17/1996	China	H04B7	005	X	

EXAMINER

DATE CONSIDERED

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*Examiner
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OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

3

Chinese Office Action for Chinese Patent Application No.: 20031010330.1

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